

FORM PTO-1449 MAY 30 2003 INFORMATION DISCLOSURE CITATION IN AN ANTICIPATION (Use several sheets if necessary)			Docket Number (Optional) 637.0015USX	Application Number 10/060,909
			Applicant Antoni, et al.	
			Filing Date January 30, 2002	Group Art Unit 2872

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,294,538	10/13/81	Ban	355	51	
RDS	5,222,112	6/22/93	Terasawa et al.	378	34	
	5,669,708	9/23/97	Mashima et al.	362	341	
RDS	5,993,010	11/30/99	Ohzawa et al.	353	99	
RDS	5,995,582	11/30/99	Terashima et al.	378	34	

RECEIVED

JUN -2 2003
TECHNOLOGY CENTER 2800

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						YES NO
RDS	0066295B1	12/8/82	Europe			X
RDS	0939341A2	9/1/99	Europe			X
RDS	0985976A2	3/15/00	Europe			X
RDS	1026547A2	8/9/00	Europe			X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

RDS	Illumination Optics Design for EUV Lithography, M. Antoni et al., SPIE Vol. 4146, p25-34 (2000)

EXAMINER	DATE CONSIDERED
RDS	9/08/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.